

Docket No.: 4006-282

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Inventors: Jia-Xing LIN et al. :
U.S. Patent Application No. *Not yet assigned* : Group Art Unit: *Not yet assigned*
Filed: *Herewith* : Examiner: *Not yet assigned*
For: METHOD OF FORMING POLY-SILICON CRYSTALLIZATION

CLAIM OF PRIORITY

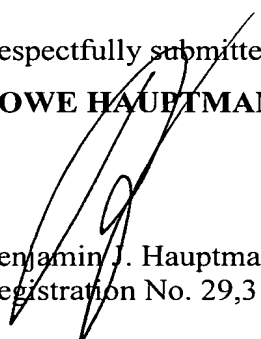
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicant hereby claims the priority of *Taiwanese Patent Application No. 92136606 filed December 23, 2003*. The certified copy will be filed in due course.

Respectfully submitted,

LOWE HAUPTMAN GILMAN & BERNER, LLP


Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 310
Alexandria, Virginia 22314
(703) 684-1111 BJH/etp
Facsimile: (703) 518-5499
Date: February 19, 2004